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** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

JAPAN 2001-398480 12/27/2001

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** 04/03/2002

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <u>[Signature]</u> Initials <u>[Initials]</u>	STATE OR COUNTRY JAPAN	SHEETS DRAWING 12	TOTAL CLAIMS 25	INDEPENDENT CLAIMS 3
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ADDRESS

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ALEXANDRIA, VA

22314

TITLE

Semiconductor device using partial SOI substrate and manufacturing method thereof

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